



<p>Substitute for form 1449A/PTO</p> <p>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</p> <p><i>(use as many sheets as necessary)</i></p>				<p>Complete if Known</p>	
Sheet	1	of	27	Application Number	10/823,836
				Filing Date	April 13, 2004
				First Named Inventor	Kramadhati V. Ravi
				Art Unit	1765
				Examiner Name	
				Attorney Docket Number	42P18240

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

Examiner Signature	/Patricia George/ (06/29/2006)	Date Considered	06/29/2006
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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

Sheet

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of

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Complete if Known

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NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
PG	2	MASUDA et al: Fabrication of a Nanostructured Diamond Honeycomb Film. Advanced Materials, VCH Verlagsgesellschaft, Weinheim, DE, Vol.12 no. 6, 3-16-2000, p. 444-447, XP000923877	
PG	3	RAMESHAM et al: Plasma Etching and Patterning of CVD Diamond at < 100 Deg C for Microelectronics Applications. Thin Solid Films, Elsevier-Sequoia S.A. Lausanne, Ch, Vol. 304, no. 1-2, July 1997, p. 245-251, XP004096481	
PG	4	PCT Search Report & Written Opinion dated 9-23-05	

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